	LABEL



U.S. PATENT APPLICATION

 SERIAL NUMBER
 FILING DATE
 CLASS
 GROUP ART UNIT

 07/863,791
 04/06/92
 430
 1507

PPLICANT

JANG F. CHEN, SAN JOSE, CA; JAMES A. MATTHEWS, MILPITAS, CA.

CONTINUING DATA************
VERIFIED

FOREIGN/PCT APPLICATIONS******
VERIFIED

FOREIGN FILING LICENSE GRANTED 05/06/92

STATE OR	SHEETS	TOTAL	INDEPENDENT	FILING FEE	ATTORNEY DOCKET NO.
COUNTRY	DRAWING	CLAIMS	CLAIMS	RECEIVED	
CA	7	23	3	\$1,010.00	57017.P025

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN 12400 WILSHIRE BLVD., 7TH FL. LOS ANGELES, CA 90025

METHOD FOR IMPROVED LITHOGRAPHIC PATTERNING IN A SEMICONDUCTOR FABRICATION PROCESS

This is to certify that annexed hereto is a true copy from the records of the United States Patent and Trademark Office of the application as filed which is identified above.

By authority of the COMMISSIONER OF PATENTS AND TRADEMARKS

Date

Certifying Officer



BAR CODE LABEL

Date



			U.S. PATENT APPLICATION					
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07/863,791		04,	/06/92	430	1503			
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l w	FOR IMPROVE		HIC PATTERNING	; IN A SEMICON	DUCTOR			
This is to certify Patent and Trad	/ that annexed lemark Office	l hereto is a tr of the applicat	ue copy from the ion which is ident	records of the Un ified above.	ited States			
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